



ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

October 10, 2025	
IGI Report Number	LG741579417
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	ROUND BRILLIANT
Measurements	9.54 - 9.60 X 6.06 MM

GRADING RESULTS

Carat Weight	3.46 CARATS
Color Grade	F
Clarity Grade	VVS 2
Cut Grade	EXCELLENT

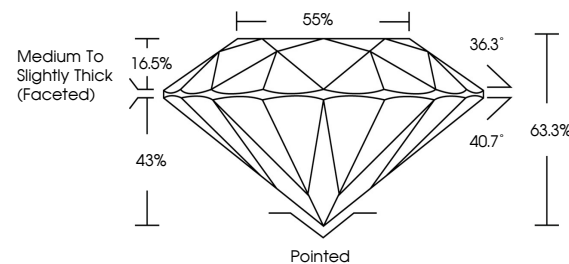
ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	 LG741579417

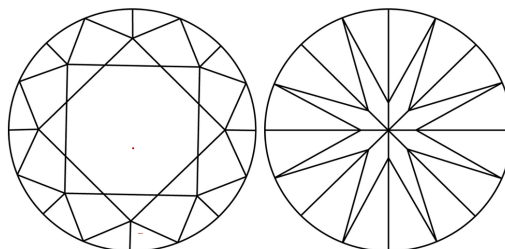
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG741579417
Report verification at igi.org

PROPORTIONS

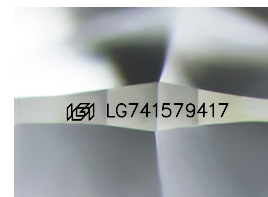


CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.



Sample Image Used

COLOR

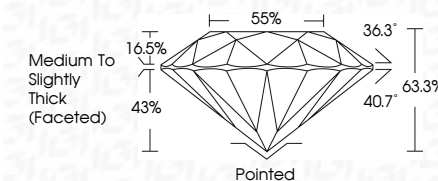
D E F G H I J Faint Very Light Light

CLARITY

FL	IF	VVS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



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www.igi.org

October 10, 2025
GI Report No LG741579417
ROUND BRILLIANT

3.46 CARATS	F	
VVS 2		
EXCELLENT		
63.3%		
55%		
Medium to Slightly Thick (Faceted)		
Pointed		
EXCELLENT		
EXCELLENT		
NONE		

Comments:
This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.